IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:		Group Art Unit: 1753
	Naoki Komai, et al.	Confirmation No.: 3159
Application No. 10/775,935))
Filed:	February 10, 2004)
For:	SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES	Examiner: Luan V. Van Output Discrepance: Luan V. Van Output Discrepance: Luan V. Van Output Discrepance: Luan V. Van
	STOP AMENDMENT hissioner for Patents	

RESPONSE TO APRIL 23, 2007 OFFICE ACTION

Dear Sir:

P.O. Box 1450

Alexandria, VA 22313-1450

This Amendment is submitted in response to the Office Action mailed April 23, 2007.

Applicant respectfully requests reconsideration of the application in view of this amendment and remarks herein.